

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

SASAKI

Serial No. 09/487,259

Filed: January 19, 2000

For: Manufacturing Method for a Semiconductor Device



Atty. Ref.: 1035-243

Group: 2825

Examiner: unknown

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Honorable Assistant Commissioner of Patents
Washington, DC 20231

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO-1449, a copy of each of which is enclosed.

The partial translations were provided to the undersigned by the applicants' foreign representative. The undersigned has no knowledge regarding the pertinency of the partially translated portions vis-à-vis the document as a whole. The partial translations are merely provided for whatever convenience they may be.

Official citation and consideration of all the attached documents is requested. Please return to the undersigned a copy of the attached PTO-1449 with the examiner's initials in the left column [MPEP §609] with the next communication.

SASAKI
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Atty Dkt: 1035-243
Art Unit: 2825

The filing of an Information Disclosure Statement shall not be construed as a representation that a search has been made [37 C.F.R. § 1.97(g)], an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists. Further, the filing of an Information Disclosure Statement shall not be construed as an admission against interest in any manner [Commissioner's Notice of January 9, 1992, 1135 O.G. 12-25 at 25].



March 16, 2000

Respectfully submitted,
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